

CERTIFICATE OF MAILING

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Docket: 0756-775

Susan J. Stiles



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: PATENT application of)
 Takashi INUSHIMA, et al.)
 Serial No. 07/971,242) Group Art Unit: 1104
 Filed: September 8, 1992) Examiner: G. Goudreau
 For: CVD APPARATUS) Date: January 18, 1994

Honorable Commissioner of Patents and Trademarks
 Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ Small entity status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a verified statement previously submitted.
- ☐ A verified statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.
- ☐ No additional fee is required.

The fee has been calculated as shown below:

(Col. 1)	(Col. 2)	(Col. 3)	Small/Large Entity	
CLAIMS	HIGHEST NO.	PRESENT		
REMAINING	PREVIOUSLY	EXTRA		
AFTER	PAID FOR			
<u>AMENDMENT</u>			<u>Rate</u>	<u>Fee</u>
Total 16 * Minus 20 **		0	x11/22	0
Indep. 5 * Minus 3 **		2	x37/74	148
First Presentation of Multiple				
Dependent Claim			+ 115/230	
			TOTAL	\$148

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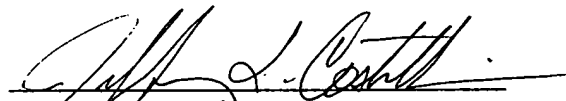
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GP 1104

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- [X] A check in the amount of \$ 148.00 to cover the filing fee is enclosed.
- [X] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380 (0756-775).
- [X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c) and 1.20 (d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380 (0756-775). A duplicate copy of this sheet is attached.

Respectfully submitted,


Jeffrey L. Costellia
Reg. No. 35,483

Sixbey, Friedman, Leedom & Ferguson, P.C.
2010 Corporate Ridge, Suite 600
McLean, Virginia 22102
(703) 790-9110

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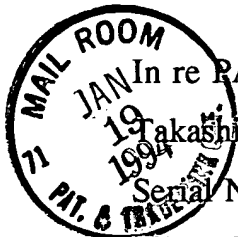
Susan J. Stiles

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of

Takashi INUSHIMA, et al.

Serial No. 07/971,242

Filed: September 8, 1992

For: CVD APPARATUS

)
)
) Art Unit: 1104
) Examiner: G. Goudreau
) Date: January 18, 1994

AMENDMENT

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

In response to the Official Action of October 18, 1993, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 17, 22, 27 and 28 as follows:

3 ~~17~~ ~~22~~ (Amended) [The] A method of [claim 16] forming a film on a substrate comprising the steps of:

placing a substrate in a reaction chamber;

introducing a reactive gas comprising at least TEOS;

exciting said reactive gas by supplying photo and electrical energies into said reaction chamber; and

depositing a film on said substrate by CVD wherein said photo and electrical energies are supplied sequentially.

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